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Attorney Docket: 071469-0307905
Client Reference: PC0070A2

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of:

ANDREJ S MITROVIC

Confirmation Number: 4269

Application No.: 10/807,439

Group Art Unit: 1763

Filed: March 24, 2004

Examiner: Ram N. Kackar

Title: METHOD AND SYSTEM FOR MONITORING RF IMPEDANCE TO DETERMINE
CONDITIONS OF A WAFER ON AN ELECTROSTATIC CHUCK

November 13, 2006

AMENDMENT

United States Patent and Trademark Office
Customer Service Window
Randolph Building
401 Dulany Street
Alexandria, VA 22314

Sir:

In response to the Office Action dated July 24, 2006, the date for response to which has been extended to November 24, 2006, by the enclosed Petition for a One-Month Extension of Time and Fee, please amend the above-captioned application as follows: